

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Shunpei YAMAZAKI

Application No. 09/620,968

Filed: July 20, 2000

For: METHOD OF FORMING INSULATION
FILMS CAPACITANCES, AND
SEMICONDUCTOR DEVICES



)

)

)

)

)

Group Art Unit: 2814

Examiner: Nathan W. Ha

Confirmation No. 4214

Date: March 7, 2005

AMENDMENT

Mail Stop **RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

Further to the Notice of Appeal filed on November 5, 2004, please amend the above identified application as follows.

Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 6 of this paper.

03/09/2005 YPOLITE1 00000057 192380 09620968

03 FC:1202 100.00 DA